I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

Attorney Docket No.: AM2119/T21300

TTC No.: 16301M-021300

Assistant Commissioner for Patents Washington, D.C. 20231

on <u>Auc. 20, 1999</u>

TOWNSEND and TOWNSEND and CREW LLP

ву: Gynda Asbroch

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Examiner:

R. Zervigon

1/6/00)

Karl Littau et al.

Art Unit:

1763

Application No.: 08/893,917

93,917 <u>AMENDMENT</u>

Filed: July 11, 1997

For: REMOTE PLASMA CLEANING SOURCE HAVING REDUCED REACTIVITY WITH A SUBSTRATE

PROCESSING CHAMBER

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

In response to the Office Action mailed August 24, 1999, please amend the above-identified application as follows:

## IN THE SPECIFICATION:

Page 1, line 16, please change "[AMAT1975/T19000]" to --08/839,111--.

Page 1, line 20, please change "[AMAT2027/T20200]" to --08/893,922--.

Page 18, line 9, please change "autotuner" to --isolator--.

Page 18, line 21, please change "320" to --324--.

Page 18, line 24, please change "340" to --330--.

Page 20, line 14, please delete the period after "15".

Page 20, line 15, please change "To" to --to--.

Page 24, line 6, please change "342" to --430--.

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